Se	arcl	n No	tes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/048,164	KURIYA ET AL.
Examiner	Art Unit
Matthew Heneghan	2124

	SEARCHED		
Class	Subclass	Date	Examiner
726	29	5/2/2007	мн
			

INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
	-		
	aterference arch	5/2/2007	МН

SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
STIC Fast & Focused Search, see notes	4/23/2007	МН
EAST Update Search, see notes	5/2/2007	МН
ACM, IEEE Searches	5/2/2007	МН
Inventor Search	5/2/2007	МН